



3723

AMENDMENT TRANSMITTAL LETTER (Large Entity)			Docket No. 35013.4000		
Applicant(s): Tim Dyer, et al.			OCT 22 2002		
Serial No. 09/836,426	Filing Date April 17, 2001	Examiner McDonald, Shantese L.	Group Art Unit 3723		
Invention: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS FOR REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE THAT INCLUDES LOW-K MATERIAL					
<p align="center"><u>TO THE ASSISTANT COMMISSIONER FOR PATENTS</u></p> <p>Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.</p>					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	33 -	33 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	6 -	6 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<p><input checked="" type="checkbox"/> No additional fee is required for amendment.</p> <p><input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ A duplicate copy of this sheet is enclosed.</p> <p><input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed.</p> <p><input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-2814 A duplicate copy of this sheet is enclosed.</p> <p><input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16.</p> <p><input type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.</p>					
 Signature			Dated: October 17, 2002		
Cynthia L. Pillote, Reg. No. 42,999 Snell & Wilmer L.L.P. One Arizona Center 400 East Van Buren Phoenix, Arizona 85004-2202 (602) 382-6296 (602) 382-6070 - Facsimile			<div><p>I certify that this document and fee is being deposited on October 17, 2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.</p><p> Signature of Person Mailing Correspondence</p><p>Suzie G. Mascari Typed or Printed Name of Person Mailing Correspondence</p></div>		
cc:					

7/A
JS
10-25-02



CERTIFICATE OF MAILING BY FIRST CLASS U.S. MAIL

I hereby certify that this Response Pursuant to 37 C.F.R. 1.8 is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box Non-Fee Amendment, Washington D.C. 20231, on:

Date: October 17, 2002 By Surge J. Mascari

-- PATENT --

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Applicant(s): Tim Dyer, et al. Attorney Docket No.: 35013.4000
Serial No.: 09/836,426 Group Art Unit: 3723
Filed: April 17, 2001 Examiner: McDonald, Shantese L.
TITLE: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS FOR REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE THAT INCLUDES LOW-K MATERIAL

RESPONSE AND AMENDMENT

Commissioner for Patents
Box Non-Fee Amendment
Washington, D.C.

Dear Sir:

Applicants hereby timely respond to the Office Action mailed August 1, 2002, within the three-month shortened statutory period to respond. Please amend claims 1, 2, 4, 12, 25, 26, 32, and 33 to read as follows and consider the remarks set forth below.

IN THE CLAIMS

1. An apparatus for polishing a surface of a workpiece, the surface including a low dielectric constant material, comprising:

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